Osiris-T

ABERROMETER | TOPOGRAPHER

The information provided by Osiris-T, a corneal topo- ocular wavefront in real time with a frame rate of up to grapher combined with a total ocular aberrometer, is in- 33 images per second: this makes it possible to measudispensable for the correct evaluation of patients who re and view changes in power and aberrations while the have, in addition to traditional low-order defects, even patient is accommodating. ternal.

ABERROMETER:

Osiris-T has a unique pyramidal sensor design that allows problems. the aberrometer to measure aberrations with a resolution of 45,000 points (at the maximum pupil diameter), with a wide dynamic range. It is also able to measure the

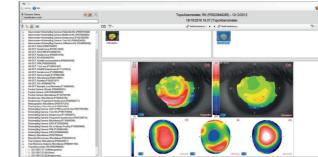
more complex ocular aberrations, either corneal or in- Phoenix software offers a wide range of analysis options, such as refractive error maps and visual simulations (PSF, MTF and convolution with optotype), which helps the clinician to understand and explain the patient's visual

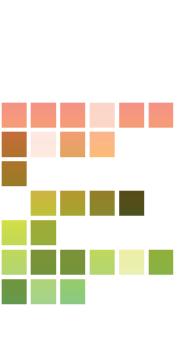
TOPOGRAPH:

Using a reflection topography system based on a 22 ring Placido disk, Osiris-T is able to measure the morphology and the corneal refractive component by means of the sagittal curvature, tangential curvature, elevation and power maps. The availabilty of consolidated synthesis parameters makes the follow-up and diagnosis of keratoconus simple and intuitive. The integration of topographry and aberrometery enables the calculation of the internal component of the wavefront.



Osiris-T uses the Phoenix software platform allowing patient data to be saved for future review and analysis, shared by all CSO devices.

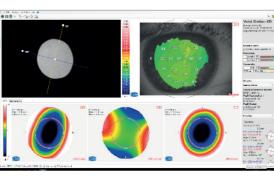






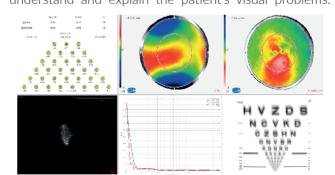
TORIC LENS ASSISTANT

to a rotation of the lens or to an incorrect calculation.



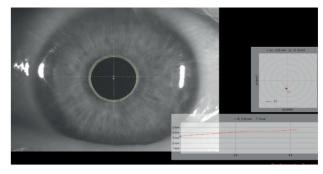
ANALYSIS SOFTWARE FOR ABERRATIONS

For the evaluation of the performances of a toric system The tool integrates with the Phoenix software, offethe combination of corneal topography imported from ring a wide range of analysis options, such as refractive CSO topographers and ocular aberration makes it possieror maps and visual simulations (PSF, MTF and conble to distinguish whether any astigmatic residue is due volution with optotype), which helps the clinician to understand and explain the patient's visual problems.



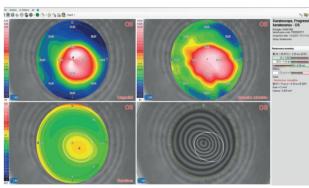
PUPILLOGRAPHY

Completely integrated with the topography of the anterior surface of the cornea, it performs the pupil measurement in scotopic (0.04 lux), mesopic (4 lux), photopic (50 lux) conditions and in dynamic mode. Knowing the center and the diameter of the pupil, is essential for many clinical procedures which seek to optimize vision quality.



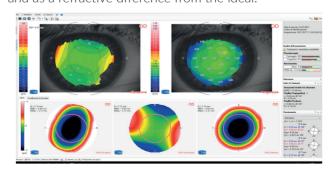
KERATOCONOUS SCREENING

Keratoconous screening software, provides the clinician with imporatant information about the patients cornea. Understanding this can help prevent complications associated with ectasia before corneal surgery is undertaken.



OCULAR WAVEFRONT

Phoenix software enables the analysis of the patient's ocular wavefront, both as a deviation from the wavefront and as a refractive dfference from the ideal.



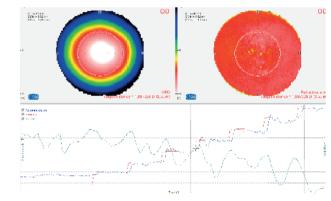
DENSITOMETR

For an objective assessment of cataract and optical media opacity evaluation, Osiris-T can acquire backlit images without reflections.



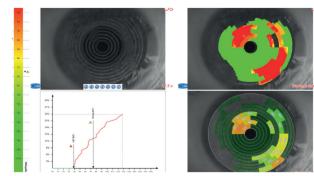
DYNAMIC ACCOMODATION

Real-time measurement of the ocular wavefront is indispensable during the evaluation of the accommodative phases. Customizable exam modes (ramps or square waves) are available to evaluate the patient's ability to focus at near.



ADVANCED ANALYSIS OF THE TEAR FILM

Placido disk technology allows for the advanced analysis of the tear film, such as NIBUT (Non Invasive Break-up Time). Based on the Ocular Surface Disease Index questionnaire (OSDI), limbal and conjunctival hyperaemia, Meibomian glands analysis, tear meniscus



analysis and tear osmolarity, calculated merging together all partial scores, provides an owerall evaluation of the clinical condition of the patient for a comprehesive diagnosis of the dry eye disease.

Osiris-T

ABERROMETER | TOPOGRAPHER

TECHNICAL DATA

In: 100-240Vac - 50/60Hz - 0.9-05A - Out: 24Vdc - 40W Power net cable with plug C14 Dimensions (HxWxD) 515 x 315 x 255mm 6.9Kg Chin rest movement 70mm ± 1mm Minimum height of the chin cup from the table 24cm Base movement (xyz) 105 x 110 x 30mm 74mm Working distance Led @850nm Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) Dioptric measurement range Measurement accuracy Class A according to UNI EN ISO 19980-2012	Data transfer	USB 3.0
Dimensions (HxWxD) 515 x 215 x 255mm Weight 6.9Kg Chin rest movement 70mm ± 1mm Minimum height of the chin cup from the table 24cm Base movement (xyz) 105 x 110 x 30mm Working distance 74mm LIGHT SOURCES	Power supply	
Weight 6.9Kg Chin rest movement 70mm ± 1mm Minimum height of the chin cup from the table 24cm Base movement (xyz) 105 x 110 x 30mm Working distance 74mm LIGHT SOURCES Aberrometer Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Power net cable	with plug C14
Chin rest movement 70mm ± 1mm Minimum height of the chin cup from the table 24cm Base movement (xyz) 105 x 110 x 30mm Working distance 74mm LUGHT SOURCES Aberrometer Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Dimensions (HxWxD)	515 x 315 x 255mm
Minimum height of the chin cup from the table Base movement (xyz) 105 x 110 x 30mm 74mm LIGHT SOURCES Aberrometer Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) Dioptric measurement range Measurement accuracy Class A according to UNI EN ISO 19980-2012	Weight	6.9Kg
Base movement (xyz) 105 x 110 x 30mm Working distance 74mm LIGHT SOURCES Aberrometer Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Chin rest movement	70mm ± 1mm
Working distance 74mm LIGHT SOURCES Aberrometer Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido Led @635nm 22 Measured points 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Minimum height of the chin cup from the table	24cm
Aberrometer Led @850nm Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Base movement (xyz)	105 x 110 x 30mm
Aberrometer Led @850nm Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range Measurement accuracy Class A according to UNI EN ISO 19980-2012	Working distance	74mm
Fixation Led @450-650nm Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	LIGHT SOURCES	
Placido Led @635nm Pupillometry and auxiliary Led @780nm ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Aberrometer	Led @850nm
Pupillometry and auxiliary ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) Dioptric measurement range Measurement accuracy Class A according to UNI EN ISO 19980-2012	Fixation	Led @450-650nm
ABERROMETRY Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Placido	Led @635nm
Points measured at maximum pupil 45000 Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Pupillometry and auxiliary	Led @780nm
Spatial resolution 41µm Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	ABERROMETRY	
Pupil size range 2-9mm Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Points measured at maximum pupil	45000
Dioptric range Sph from -25D to +15D; Cyl up to 10D Repeatability 0.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Spatial resolution	41µm
Repeatability O.05D on test eyes TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Pupil size range	2-9mm
TOPOGRAPHY Placido rings 22 Measured points 5632 Topographic covering (in 43D) Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Dioptric range	Sph from -25D to +15D; Cyl up to 10D
Placido rings 22 Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Repeatability	0.05D on test eyes
Measured points 5632 Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	TOPOGRAPHY	
Topographic covering (in 43D) 10mm Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Placido rings	22
Dioptric measurement range from 1D to 100D Measurement accuracy Class A according to UNI EN ISO 19980-2012	Measured points	5632
Measurement accuracy Class A according to UNI EN ISO 19980-2012	Topographic covering (in 43D)	10mm
	Dioptric measurement range	from 1D to 100D
Compatibility with standard DICOM v3 (IHE integration profile EYECARE Workflow)	Measurement accuracy	Class A according to UNI EN ISO 19980-2012
	Compatibility with standard	DICOM v3 (IHE integration profile EYECARE Workflow)

MINIMUM SYSTEM REQUIREMENT

PC: 4 GB RAM - Video Card 1 GB RAM (not shared) resolution 1024 x 768 pixels - USB 3.0 type A Operating system: Windows XP, Windows 7 and Windows 10 (32/64 bit).

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